

EAST- [10713214.wsp.1]

File View Edit Tools Window Help

Drafts
 Pending
 Active
 L3: (177) 2 and vertical\$2
 L4: (11) memory and vertical near nanotube\$1
 L2: (352) memory and nanotube
 L5: (1) ("6313503").PN.
 Failed
 Saved
 Favorites
 Tagged (1)
 UDC
 Queue
 Trash

Search [] [] Browse Queue Clear

DBs: USPAT: US-PGPUB, EPO, JPO ☐ Plurals

Default operator: OR ☒ Highlight all hit terms initially

memory and nanotube

☐ BRS term
 ☐ BRS term
 ☐ Image
 ☐ Text
 ☐ HTML

	U	I	Document ID	Issue Date	Pages	Title	Current OR	Current XRef
156	<input type="checkbox"/>	<input type="checkbox"/>	US 20030148086 A1	20030807	15	Controlled growth of single-wall carbon nanotubes	428/293.7	423/447.3
157	<input checked="" type="checkbox"/>	<input type="checkbox"/>	US 20030144185 A1	20030731	30	Cyclic peptide structures for molecular scale electronic and photonic devices	514/9	
158	<input checked="" type="checkbox"/>	<input type="checkbox"/>	US 20030134267 A1	20030717	11	Sensor for detecting biomolecule using carbon nanotubes	435/4	435/287.2; 435/6
159	<input checked="" type="checkbox"/>	<input type="checkbox"/>	US 20030133865 A1	20030717	19	Single-wall carbon nanotube alewives, process for making, and compositions	423/447.1	
160	<input checked="" type="checkbox"/>	<input type="checkbox"/>	US 20030132432 A1	20030717	101	Semiconductor device	257/17	257/E29.304
161	<input checked="" type="checkbox"/>	<input type="checkbox"/>	US 20030127985 A1	20030710	25	Discharge lamp	313/594	
162	<input checked="" type="checkbox"/>	<input type="checkbox"/>	US 20030127593 A1	20030710	41	Apparatus and method for wafer pattern inspection	250/310	
163	<input checked="" type="checkbox"/>	<input type="checkbox"/>	US 20030124837 A1	20030703	35	Methods of making electromechanical three-trace junction devices	438/629	
164	<input checked="" type="checkbox"/>	<input type="checkbox"/>	US 20030124572 A1	20030703	43	Assay electrode having immobilized lipid/protein layers, methods of making the	435/6	205/777.5; 435/7.9
165	<input checked="" type="checkbox"/>	<input type="checkbox"/>	US 20030124325 A1	20030703	34	Electromechanical three-trace junction devices	428/209	174/255
166	<input type="checkbox"/>	<input type="checkbox"/>	US 20030122133 A1	20030703	7	Semiconductor device using single carbon nanotube and method of manufacturing of	257/77	